

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Hisatsugu KURITA et al.

Title:

SILICON WAFER CLEANING METHOD

Appl. No.:

10/645,911

Filing Date: 08/22/2003

Examiner:

Michail Kornakov

Art Unit:

1746

AMENDMENT TRANSMITTAL

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

Transmitted herewith is an amendment in the above-identified application.

-] Small Entity status under 37 C.F.R. § 1.9 and § 1.27 has been established by a ſ previous assertion of Small Entity status.
-] Assertion of Small Entity status is enclosed.
 - The fee required for additional claims is calculated below:

	Claims As Amended		Previously Paid For		Extra Claims Present		Rate		Additional Claims Fee
Total Claims:	5	-	20	=	0	X	\$50.00	=	\$0.00
Independent Claims:	1	-	3	=	0	x	\$200.00	=	\$0.00
First p	oresentation	of a	ny Multiple I	Depen	dent Claims:	+	\$360.00	=	\$0.00
					CLAIMS	FE	E TOTAL	=	\$0.00

] Applicant hereby petitions for an extension of time un	der 37 C.F.R. §1.136(a)) for the	
total number of months checked below:			
Extension for response filed within the first month:	\$120.00	\$0.00	
Extension for response filed within the second month:	\$450.00	\$0.00	
Extension for response filed within the third month:	\$1,020.00	\$0.00	
Extension for response filed within the fourth month:	\$1,590.00	\$0.00	
] Extension for response filed within the fifth month:	\$2,160.00	\$0.00	
EXTENSI	ON FEE TOTAL:	\$0.00	
Statutory Disclaimer Fee under 37 C.F.R. 1.20(d):	\$130.00	\$0.00	
	IER FEE TOTAL:	\$0.00	
Small Entity Fees Apply (subtract ½ of above):		\$0.00	
TOTAL FEE:			
	total number of months checked below:] Extension for response filed within the first month:] Extension for response filed within the second month:] Extension for response filed within the third month:] Extension for response filed within the fourth month:] Extension for response filed within the fifth month: EXTENSION Statutory Disclaimer Fee under 37 C.F.R. 1.20(d): CLAIMS, EXTENSION AND DISCLAIM	Extension for response filed within the first month: \$120.00 Extension for response filed within the second month: \$450.00 Extension for response filed within the third month: \$1,020.00 Extension for response filed within the fourth month: \$1,590.00 Extension for response filed within the fifth month: \$2,160.00 EXTENSION FEE TOTAL: Statutory Disclaimer Fee under 37 C.F.R. 1.20(d): \$130.00 CLAIMS, EXTENSION AND DISCLAIMER FEE TOTAL: Small Entity Fees Apply (subtract ½ of above):	

If any extensions of time are needed for timely acceptance of papers submitted herewith, applicant hereby petitions for such extension under 37 C.F.R. §1.136 and authorizes payment of any such extensions fees to Deposit Account No. 19-0741.

Please direct all correspondence to the undersigned attorney or agent at the address indicated below.

Respectfully submitted,

Date 5 25 06

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AMENDMENT AND REPLY UNDER 37 CFR 1.111

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated February 23, 2006, concerning the above-referenced patent application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this document.

Remarks/Arguments begin on page 3 of this document.

Please amend the application as follows: